



1763

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: YOUNG HOON PARK)
SERIAL NO.: 09/848,533)
FILING DATE: May 03, 2001)
FOR: ATOMIC LAYER DEPOSITION (ALD))
THIN FILM DEPOSITION EQUIPMENT)
HAVING CLEANING APPARATUS AND)
CLEANING METHOD)

)Group Art No.: 1763

)Examiner: J.R. Lund

RECEIVED
AUG 19 2003
1763

RESPONSE TO RESTRICTION REQUIREMENT WITH AMENDMENT,
PURSUANT TO 37 C.F.R. §1.111

The Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir or Madam:

In response to a Restriction Requirement of July 15, 2003, please enter and consider the following:

Amendment to the Claims, beginning on page 2 of this paper; and

Remarks, beginning on page 3 of this paper.